Technical University of Denmark



Effect of Functional Nano Channel Structures Different Widths on Injection Molding and Compression Molding Replication Capabilities

Calaon, Matteo; Tosello, Guido; Garnaes, J.; Hansen, Hans Nørgaard

Publication date: 2015

Document Version Peer reviewed version

Link back to DTU Orbit

Citation (APA):

Calaon, M., Tosello, G., Garnaes, J., & Hansen, H. N. (2015). Effect of Functional Nano Channel Structures Different Widths on Injection Molding and Compression Molding Replication Capabilities. Abstract from 31st International Conference of the Polymer Processing Society, Jeju Island, Korea, Republic of.

DTU Library Technical Information Center of Denmark

General rights

Copyright and moral rights for the publications made accessible in the public portal are retained by the authors and/or other copyright owners and it is a condition of accessing publications that users recognise and abide by the legal requirements associated with these rights.

• Users may download and print one copy of any publication from the public portal for the purpose of private study or research.

- You may not further distribute the material or use it for any profit-making activity or commercial gain
- You may freely distribute the URL identifying the publication in the public portal

If you believe that this document breaches copyright please contact us providing details, and we will remove access to the work immediately and investigate your claim.

Effect of Functional Nano Channel Structures Different Widths on Injection Molding and Compression Molding Replication Capabilities

Calaon M.^a*, Tosello G.^a, Garnaes J.^b, Hansen H.N.^a

^a Department of Mechanical Engineering, Technical University of Denmark, Denmark ^bDanish Foundamental Metrology, Denmark *mcal@mek.dtu.dk

Abstract. The present study investigates the capabilities of the two employed processes, injection molding (IM) and injection compression molding (ICM) on replicating different channel cross sections. Statistical design of experiment was adopted to optimize replication quality of produced polymer parts with the two different molding technologies. Focus of the experimental work was the assessment of the IM and ICM processes capabilities to replicate different channels widths (240 nm, 440 nm and 1040 nm) at different positions from the gate based on the deviations of their dimensions from the corresponding geometries measured in the nickel master. Results presented as main effect plot of channel depth deviation from ideal nickel master and polymer replicated features are reported.

Keywords: Injection molding, Lab-on-a-chip, nano metrology. PACS: orcid.org/0000-0002-9437-9829

MODLING EXPERIMENTS

Functional structures are represented by nano channels gratings manufactured perpendicularly to main carrier micro channels, aimed at transporting molecular solutions with DNA chains [1]. Based on the optimization results from the experimental injection molding campaign an additional design of experiment (DOE) was run for the compression molding experiments testing effects of different compression gap and switch over point levels. The output of analysis result was based on ISO 5436 [2] step height measurements performed using a calibrated atomic force microscope [3].

RESULTS

Effects of the different settings levels within the optimal processes windows produced maximum channels height variation of maximum 7 nm from original nickel dimension. The maximum variation was quantified for nominal channels width of 240 nm produced by injection molding. Pitch distance of 5 μ m for the produced functional channels gratings enabled the polymer to flow in between trances resulting in nanometer range (± 5 nm) product replication fidelity. Inside this tolerance range the quantified replication quality observed for the different channels width molded at different process conditions was independent by the adopted process.

ACKNOWLEDGMENTS

The present research was carried out within the National Danish Strategic Research Centre PolyNano (http://www.polynano.org/) supported by the Danish Council for Strategic Research (DSF grant no. 10-092322). The collaboration of the Danish Metrology Institute (DFM) and the Scanning Probe Microscopy Group is greatly acknowledged.

REFERENCES

- 1. S. Tanzi et.al. J Micromech. Microeng., 22:11, 2011.
- 2. ISO 5436 part 1:200. Geometrical product specification (gps) -surface texture: profile method measurement standard material measure, 2000.
- 3. J. Garnaes et.al. Precision Engineering. 2003, pp. 91-98.